

IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.: 10/602,468

PATENT

Filing Date: June 23, 2003

Attorney Docket No. 101453-00103

Inventor(s): **Venkat SELVAMANAICKAM**

SP#156/157

Group Art Unit: 1734

Examiner Name: Not Yet Assigned

Customer No.: 026304

Title: **METALORGANIC CHEMICAL VAPOR
DEPOSITION (MOCVD) PROCESS AND
APPARATUS TO PRODUCE MULTI-LAYER
HIGH-TEMPERATURE
SUPERCONDUCTING (HTS) COATED TAPE**

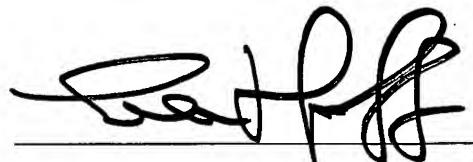
Mail Stop _____
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

REQUEST TO MAKE SPECIAL

Pursuant to 37 CFR 1.102 applicants hereby request the USPTO to accelerate the processing of the above identified application for patent. The captioned application for patent relates to superconductive materials, processes and techniques for their manufacture and/or use and is within the scope of the Presidential mandate to accelerate prosecution of applications involving superconductivity.

Respectfully submitted,

By:



Serle Mosoff
 Registration No. 25,900
 Attorney for Applicant(s)

KMZ Rosenman
 575 Madison Ave.
 New York, NY 10022-2585
 Telephone: (212) 940-8717
 Facsimile: (212) 940-8986
 Customer No.: 026304

